L Number	Hits	Search Text	DB	Time stamp
1	377	((ge germanium) near2 (Si silicon)) near12 interface	USPAT;	2004/02/12 19:46
İ			US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
2	16	(((ge germanium) near2 (Si silicon)) near12 interface) near12	USPAT;	2004/02/12 19:53
		(nanometer nm ang angstoms \$3ang.\$1 micron micrometer	US-PGPUB;	
		\$3mu.m)	EPO; JPO;	
İ			DERWENT;	
]	1020	//go gormanium) noor2 (Si ciliaan)) noor12 (nanomatar nm	IBM_TDB USPAT;	2004/02/12 19:54
3	1030	((ge germanium) near2 (Si silicon)) near12 (nanometer nm ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)	US-PGPUB;	2004/02/12 19.54
		ang angstoms \$5ang.\$1 micron micrometer \$5md.m/	EPO; JPO;	
			DERWENT;	
]			IBM_TDB	
4	o	(((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT;	2004/02/12 19:53
		ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB;	
		sililcide	EPO; JPO;	
		•	DERWENT;	
			IBM_TDB	
5	201	(((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT;	2004/02/12 20:02
		ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB;	
		(salicide silicide)	EPO; JPO;	
			DERWENT;	
	0.4	(1)	IBM_TDB	0004/00/40 40:53
6	21	(((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT; US-PGPUB;	2004/02/12 19:53
		ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) same	EPO; JPO;	
		(salicide silicide)	DERWENT;	
			IBM_TDB	
7	380	((ge germanium) near2 (Si silicon)) near12 (silicide salicide)	USPAT;	2004/02/12 19:54
'	300	(tge germaniam) hearz (er sineem) hear iz (sineide saneide)	US-PGPUB;	200 1102112 10101
			EPO; JPO;	
			DERWENT;	,
			IBM_TDB	
8	46	(((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT;	2004/02/12 19:54
		ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB;	
		(((ge germanium) near2 (Si silicon)) near12 (silicide salicide))	EPO; JPO;	
			DERWENT;	
	00	////na manusani/man naar2 (Si ailiaan)) naar42 (nanamatar nm	IBM_TDB USPAT;	2004/02/12 20:02
9	23	((((ge germanium) near2 (Si silicon)) near12 (nanometer nm ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB:	2004/02/12 20:02
		(((ge germanium) near2 (Si silicon)) near12 (silicide	EPO; JPO;	
		salicide))) and @ad <20000306	DERWENT;	
		Janoido/// and @dd 12000000	IBM TDB	
10	13	((((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT;	2004/02/12 19:54
'-	,5	ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB;	
		(((ge germanium) near2 (Si silicon)) near12 (silicide	EPO; JPO;	
]		salicide))) and @rlad <20000306	DERWENT;	
		,,,	IBM_TDB	
11	28	(((((ge germanium) near2 (Si silicon)) near12 (nanometer nm	USPAT;	2004/02/12 20:01
		ang angstoms \$3ang.\$1 micron micrometer \$3mu.m)) and	US-PGPUB;	
		(((ge germanium) near2 (Si silicon)) near12 (silicide	EPO; JPO;	
		salicide))) and @ad <20000306) (((((ge germanium) near2	DERWENT;	
		(Si silicon)) near12 (nanometer nm ang angstoms \$3ang.\$1	IBM_TDB	
		micron micrometer \$3mu.m)) and (((ge germanium) near2		
12	2006	(Si silicon)) near12 (silicide salicide))) and @rlad <20000306)	USPAT;	2004/02/12 20:02
12	206	(Ge germanium) near3 (migrat\$3 diffus\$4 mov\$3) near12	US-PGPUB;	2007/02/12 20:02
		(surface interface face)	EPO; JPO;	
			DERWENT;	
]			IBM TDB	
L				

13	35	((Ge germanium) near3 (migrat\$3 diffus\$4 mov\$3) near12	USPAT;	2004/02/12 20:02
		(surface interface face)) and (salicide silicide)	US-PGPUB;	
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
14	21	(((Ge germanium) near3 (migrat\$3 diffus\$4 mov\$3) near12	USPAT;	2004/02/12 20:02
		(surface interface face)) and (salicide silicide)) and @ad	US-PGPUB;	
		<20000306	EPO; JPO;	
			DERWENT;	
			IBM_TDB	0004/00/40 00 00
15	10	(((Ge germanium) near3 (migrat\$3 diffus\$4 mov\$3) near12	USPAT;	2004/02/12 20:02
		(surface interface face)) and (salicide silicide)) and @rlad	US-PGPUB;	
		<20000306	EPO; JPO;	
			DERWENT;	
16	22	////Co gormanium\ noor3 (migrat\$3 diffus\$4 mov\$3) noor13	IBM_TDB USPAT:	2004/02/12 20:22
	23	((((Ge germanium) near3 (migrat\$3 diffus\$4 mov\$3) near12 (surface interface face)) and (salicide silicide)) and @ad	US-PGPUB;	2004/02/12 20.22
		<pre>(surface interface face) and (salicide silicide) and @ad (20000306) ((((Ge germanium) near3 (migrat\$3 diffus\$4</pre>	EPO; JPO;	
		mov\$3) near12 (surface interface face)) and (salicide	DERWENT;	
		silicide)) and @rlad <20000306)	IBM TDB	
18	890	(cabral carruthers harper lavoie roy wang).in. and	USPAT:	2004/02/12 20:24
	030	(international adj business adj machines).asn.	US-PGPUB:	200 11021 12 2012 1
	1	(International adj baomood daj masimiss).dom	EPO; JPO;	
			DERWENT:	
			IBM_TDB	
19	3	(((ge germanium) near2 (Si silicon)) near12 interface) and	USPAT;	2004/02/12 20:24
		((cabral carruthers harper lavoie roy wang).in. and	US-PGPUB;	
		(international adj business adj machines).asn.)	EPO; JPO;	
			DERWENT;	
	1		IBM_TDB	